



Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Continued)

TSMC-02-0015C

Application Number

10/679,768

Applicant

Tuo-Hung Hou et al.

Filing Date

10/06/03

Group Art Unit

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
nd	5960289	9/28/99	Tsui et al.	438	275	6/22/98
W	6159782	12/12/00	Xiang et al.	438	197	8/5/99
Y	6265325	7/24/01	Cao et al.	438	763	4/26/99
Y	6248675	6/19/01	Xiang et al.	438	926	8/5/99

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

nd	Article "Outlook on New Transistor Materials," by
	L. Peters in Semiconductor International,
	Oct. 1, 2001 edition.

EXAMINER

H. P. [Signature]

DATE CONSIDERED

9/16/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.